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ATTORNEY DOCKET NO. CONFIRMATION NO. FIRST NAMED INVENTOR APPLICATION NO. FILING DATE 07/28/2003 Chich Shang Chang 10112521 7424 10/628,893 **EXAMINER** 34283 7590 05/04/2005 **QUINTERO LAW OFFICE** FOURSON III, GEORGE R 1617 BROADWAY, 3RD FLOOR ART UNIT PAPER NUMBER SANTA MONICA, CA 90404

DATE MAILED: 05/04/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

10/628,893 CHANG ET AL.	
Office Action Summary Examiner Art Unit	
George Fourson 2823	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply	
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).	
Status	
1) Responsive to communication(s) filed on	
2a) This action is <b>FINAL</b> . 2b) ⊠ This action is non-final.	
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is	
closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.	
Disposition of Claims	
4) Claim(s) 1-7 is/are pending in the application.	
4a) Of the above claim(s) is/are withdrawn from consideration.	
5) Claim(s) is/are allowed.	
6)⊠ Claim(s) <u>1-7</u> is/are rejected.	
7) Claim(s) is/are objected to.	
8) Claim(s) are subject to restriction and/or election requirement.	
Application Papers	
9)☐ The specification is objected to by the Examiner.	
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.	
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).	
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).	
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.	
Priority under 35 U.S.C. § 119	
12)⊠ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a)⊠ All b)□ Some * c)□ None of:	
<ol> <li>Certified copies of the priority documents have been received.</li> </ol>	
2. Certified copies of the priority documents have been received in Application No	
3. Copies of the certified copies of the priority documents have been received in this National Stage	
application from the International Bureau (PCT Rule 17.2(a)).	
* See the attached detailed Office action for a list of the certified copies not received.	
Attachment(s)	
1) Notice of References Cited (PTO-892)  4) Interview Summary (PTO-413)	
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) Paper No(s)/Mail Date	
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)  Paper No(s)/Mail Date  5) Notice of Informal Patent Application (PTO-152)  6) Other:	

Application/Control Number: 10/628,893

Art Unit: 2823

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-7 are rejected under 35 U.S.C. 103(a) as being unpatentable over the combination of Henley et al 2002/0106870, Bachrach et al, and Murphy et al.

Bachrach et al discloses formation of a-Si layer 20 [0056] on glass substrate 5 [0058], implantation of hydrogen within donor substrate 70 [0050], bonding of donor substrate to layer 20 and controlled cleaving to separate donor wafer from the bonded structure leaving a transferred layer of Si on glass substrate 5 [0065]. The reference does not disclose use of laser in the controlled cleaving process or smoothing by annealing and polishing.

Henley et al discloses chemical mechanical polishing following laser initiated controlled cleaving process of a hydrogen implanted donor wafer [0074, 0077,0060,0034].

Murphy et al discloses annealing and polishing to smooth a wafer subsequent to splitting after hydrogen implantation.

It would have been obvious to one of ordinary skill in the art to combine the teachings of Henley et all and Murphy et all with those of Bachrach et all to enable smoothing of the transferred layer.

Bachrach et al discloses that the thickness of the donor portion 85 is determined by the depth of the implant process used to generate dislocations 75 [0067]. The disclosed implant energy and depth overlaps that recited in claims 6 and 7 [0050]. The implant energy and implant dose disclosed by Henley et al overlaps that recited in claim 6 [0026].

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The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to George Fourson whose telephone number is (571) 272-1860. The examiner can normally be reached on Monday through Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Olik Chaudhuri, can be reached on (571) 272-1855. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

George Fourson Primary Examiner Art Unit 2823

GFourson May 1, 2005